



[20103 00201]

POWER OF ATTORNEY BY ASSIGNEE OF ENTIRE INTEREST

Sceptre Electronics Limited, as assignee of the entire right, title, and interest in the application for patent entitled **DEVICE FOR FORMING NANOSTRUCTURES ON THE SURFACE OF A SEMICONDUCTOR WAFER BY MEANS OF ION BEAMS**, filed February 25, 2002 and assigned Serial No. 10/069,656, hereby appoints Patrick J. Fay (Reg. No. 35,508) and Oleg F. Kaplun (Reg. No. 45,559) as its attorneys/agents with full power of substitution and revocation, to prosecute this application and to transact all business in the U.S. Patent and Trademark Office connected therewith.

Please address all communications regarding this application to:

Oleg F. Kaplun, Esq.
Fay Kaplun & Marcin, LLP
100 Maiden Lane, 17th Floor
New York, New York 10038

Please direct all contacts to Oleg F. Kaplun at (212) 898-8819 or via email at okaplun@fkmipaw.com.

Sceptre Electronics Limited

Dated: 22/05/02

By: [Signature]

Name: E S MARCIN

Title: DIRECTOR

Address: Belknap House,

Highgate Street, S. Hackensack,
Jersey

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